NOTES:

- SUBSTRATE: Fused Silica
- 2. SURFACE \$1 TO BE PARALLEL TO SURFACE \$2 TO WITHIN <3 ARCMINS
- 3. COATING (APPLY ACROSS COATING APERTURE)

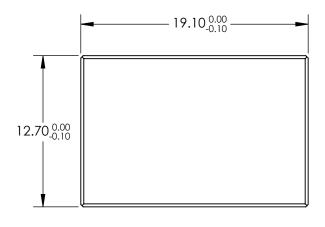
S1: R(ABS) >99.8% @ 355nm DAMAGE THRESHOLD, PULSED: 15 J/cm² @ 1030nm, 20ns, 20Hz

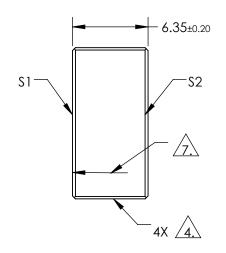
S2: NONE

4. FINE GROUND SURFACE

- 5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
- 6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY **ACROSS CLEAR APERTURE**

ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS **TOWARDS SURFACE S1**





PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

	\$1	\$2				@	
SHAPE	PLANO	PLANO				Edmund Optic	C®
SURFACE QUALITY	10-5	COMMERCIAL POLISH					,S
SURFACE FLATNESS	0.10 WAVE	N/A		1		12.7 x 19.1mm 355nm 0-45°, Nd:YAG Lo	oser
MIN CLEAR APERTURE	10.80 x 16.24	N/A	THIRD ANGLE PROJECTION		TITLE	Line Mirror	
MIN COATNG APERTURE	10.80 x 16.24	N/A		1			CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	39623	SHEET 1 OF 1